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A Ford  
5/28/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/212,726  
Filing Date ..... December 15, 1998  
Inventor ..... Klaus F. Schuegraf  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2812  
Examiner ..... Not Known  
Attorney's Docket No. .... MI22-1098  
Title: Semiconductor Processing Methods of Chemical Vapor  
Depositing SiO<sub>2</sub> on a Substrate

Assistant Commissioner for Patents  
Washington, D.C. 20231

RECEIVED  
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Sir:

ASSOCIATE POWER OF ATTORNEY

Please recognize Frederick M. Fliegel, Reg. No. 36,138; D. Brent Kenady, Reg. No. 40,045; James E. Lake, Reg. No. 44,854; and Bernard Berman, Reg. No. 37,279; whose post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington 99201-3828, as associate attorneys or agents in the above-entitled application.

Date:

5/12/00

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